

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT:	Masaki Shioya	GROUP: 2121
SERIAL NO:	10/822,266	EXAMINER: R. Hartman, Jr.
FILED:	April 8, 2004	CONFIRMATION: 2711
FOR:	FACILITY CONTROL MONITOR METHOD AND FACILITY CONTROL MONITOR APPARATUS	

Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

RESPONSE UNDER 37 C.F.R. 1.116

In response to the Office Action mailed February 21, 2007, the following amendments and remarks are respectfully submitted in connection with the above-identified application.